



Docket No.: 50212-535

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Yoshiki NISHIBAYASHI, et al.	:	Confirmation Number: 8079
Serial No.: 10/661,591	:	Group Art Unit: 1765
Filed: September 15, 2003	:	Examiner: Unknown
For: MICROFABRICATED DIAMOND ELEMENT AND METHOD OF FABRICATING MICROFABRICATED DIAMOND ELEMENT	:	

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.


The relevance of the references listed on attached Form 1449 is discussed in the present specification.

10/661,591

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION

 ATTY. DOCKET NO.
50212-535

 SERIAL NO.
10/661,591

 APPLICANT
Yoshiki NISHIBAYASHI, et al.

 FILING DATE
September 15, 2003

 GROUP
1765

(PTO-1449)

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US			
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes - Number & Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP P2002-75171A	03/15/2002	JAPAN FINE CERAMICS CENTER SUMITOMO ELECTRIC IND LTD		(Japan w/English Abstract)	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		New Diamond (Japan New Diamond Forum) Vol. 17, No. 4 (2001) p. 14-15, 5-1
		Extended Abstracts (The 47th Spring Meeting); The Japan Society of Applied Physics and Related Societies, No. 1 30a-YQ-3 (p. 377)
		Extended Abstracts (The 46th Spring Meeting); The Japan Society of Applied Physics and Related Societies, No. 1 30p-M-12 (p. 415)
		Extended Abstracts (The 62nd Autumn Meeting); The Japan Society of Applied Physics and Related Societies, No. 3 13a-ZK-5 (p. 782)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.